



1763

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT: YOUNG HOON PARK)
SERIAL NO.: 09/848,533) Group Art No.: 1763
FILING DATE: May 03, 2001) Examiner: J.R. Lund
FOR: ATOMIC LAYER DEPOSITION (ALD))
THIN FILM DEPOSITION EQUIPMENT)
HAVING CLEANING APPARATUS AND)
CLEANING METHOD)

RECEIVED
AUG 19 2003
1763

RESPONSE TO RESTRICTION REQUIREMENT WITH AMENDMENT,
PURSUANT TO 37 C.F.R. §1.111

The Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir or Madam:

In response to a Restriction Requirement of July 15, 2003, please enter and consider the following:

Amendment to the Claims, beginning on page 2 of this paper; and

Remarks, beginning on page 3 of this paper.